

Notice of References Cited	Application/Control No. 10/587,163		Applicant(s)/Patent Under Reexamination KUBO ET AL.	
	Examiner Shannon Gardner		Art Unit 1795	Page 1 of 1

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	U	Machine translation of Abe et al. (JP 2002050413, published 15.02.2002, accessed 8/6/2009)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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